PATENTS

APR 1 L TOTAL STEEL TO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of

Hiromi YAMAMOTO et al.

Serial No. 10/057, 949

GROUP 2651

Filed January 29, 2002

METHOD AND APPARATUS FOR DETERMINING THE KIND OF OPTICAL DISK

INFORMATION DISCLOSURE STATEMENT

RECEIVED

Assistant Commissioner for Patents

APR 2 6 2002

Washington, D.C. 20231

Technology Center 2600

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed sheet.

A concise explanation of the relevance of these items is given on pages 2 and 3 of the present specification.

Respectfully submitted,

YOUNG & THOMPSON

By

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Telephone: 703/521-2297

April 24, 2002

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				ATTY. DOCKET NO. 8013-1003		SERIAL NO. 10/057,949	
				APPLICANT Hiromi YAMAMOTO et al.			
(37 CFR 1.98(b))			FILING DATE January 29, 2002		GROUP 2651		
			.S. PATE	NT DOCUMENTS			
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	AA	5,764,610	06/98	YOSHIDA et al.			
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•	FO	REIGN PATENT O	R PUBLISH	IED FOREIGN PATEI	NT APP	LICATIO	N
		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
	AL	0 784 321	07/97	EUROPE			
	AM	2851597	11/98	JAPAN			
	AN	9-147397	06/97	JAPAN			
	AO	9-198779	07/97	JAPAN			•
	AP	9-312057	12/97	JAPAN			
	AQ	2000-149392	05/00	JAPAN			
	AR	2000-187928	07/00	JAPAN			
	AS						
OTHER D	OCU	MENTS (Including	Author, Tit	tie, Date, Relevant Pa	iges, Pla	ce of Pu	blication)
	АТ						
	AU						
EXAMI	NER			DATE CONSIDE	RED		

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.